

S&H Form: (2/01) DOCKET NO. 1572.1117

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In	re	Patent	Application	of:
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Kwang-il KIM et al.

Serial No: 10/682,244

Group Art Unit: 3652

Confirmation No. 5449

Filed: July 28, 2003

Examiner:

For:

SEMICONDUCTOR WAFER TRANSFER APPARATUS

## REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

It is requested that the first inventor's first name on the Official Filing Receipt be corrected. The correct first inventor's first name is Kwang-IL Kim, as is evidenced by the Declaration, attached to the application as filed. For the convenience of the Patent and Trademark Office, attached is a photocopy of the original receipt on which the errors have been noted in red.

It is requested that a corrected Official Filing Receipt be issued in this application.

By:

Respectfully submitted,

STAAS, & HALSEY LLF

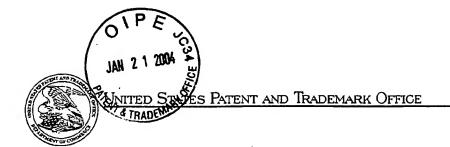
Date: January 21, 2004

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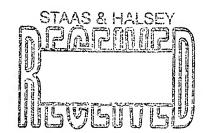


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**CONFIRMATION NO. 5449** 

21171 STAAS & HALSEY LLP SUITE 700 1201 NEW YORK AVENUE, N.W. WASHINGTON, DC 20005



FILING RECEIPT OC000000011631918\*

Date Mailed: 01/08/2004

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Applicant(s)

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**Assignment For Published Patent Application** 

SAMSUNG Electronics Co., Ltd., Suwon-city, KOREA, REPUBLIC OF;

Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2002-64648 10/22/2002

If Required, Foreign Filing License Granted: 01/06/2004

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Non-Publication Request: No

Early Publication Request: No

Title

Semiconductor wafer transfer apparatus

414

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